



03500.015730.

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of: )  
TAKASHI IWAKI ET AL. )  
Appln. No.: 09/941,782 )  
Filed: August 30, 2001 )  
For: ELECTRON-EMITTING )  
DEVICE, ELECTRON SOURCE )  
AND METHOD FOR )  
MANUFACTURING IMAGE- )  
FORMING APPARATUS )

Examiner: P. Macchiarolo  
Group Art Unit: 2875  
July 10, 2003

Mail Stop DD  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

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INFORMATION DISCLOSURE STATEMENT

Sir:

In compliance with the duty of disclosure under 37 C.F.R. § 1.56 and in accordance with the practice under 37 C.F.R. §§ 1.97 and 1.98, the Examiner's attention is directed to the documents listed on the enclosed Form PTO-1449. Copies of the listed documents are also enclosed.

The Examiner's attention is also directed to the following U.S. application:

<u>APPLICATION NO.</u>	<u>FILING DATE</u>	<u>GROUP ART UNIT</u>
10/370,662	2/24/03	1762

A copy of the cited application is enclosed.

07/21/2003 WABRHAM1 00000048 09941782

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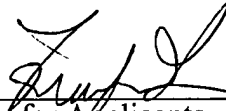
### CONCLUSION

It is respectfully requested that the above information be considered by the Examiner and that a copy of the enclosed Form PTO-1449 be returned indicating that such information has been considered.

We also enclose a check for the required fee of \$180.00 to cover the Information Disclosure Statement under 37 C.F.R. 1.97(c)(2).

Applicants' undersigned attorney may be reached in our New York office by telephone at (212) 218-2100. All correspondence should continue to be directed to our address given below.

Respectfully submitted,



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Attorney for Applicants  
Frank A. DeLucia  
Registration No. 42,476

FITZPATRICK, CELLA, HARPER & SCINTO  
30 Rockefeller Plaza  
New York, New York 10112-3801  
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FORM PTO 1449 (modified)  U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE  LIST OF REFERENCES CITED BY APPLICANT(S) (Use several sheets if necessary)				ATTY DOCKET NO. <b>03500.015730</b>		APPLICATION NO. <b>09/941,782</b>	
				APPLICANT <b>TAKASHI IWAKI ET AL.</b>			
				FILING DATE <b>AUGUST 30, 2001</b>		GROUP <b>2875</b>	

U.S. PATENT DOCUMENTS							
*EXAMINER INITIAL	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE	
	2002/0117670	8/2002	Horiguchi et al.	257	59		

FOREIGN PATENT DOCUMENTS							
	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION YES/NO/ OR ABSTRACT	
	EP 1 184 886 A1	3/2002	EPO	H01J	9/02		
	JP 11-120901	4/1999	Japan	H01J	9/02	Abstract	

OTHER DOCUMENT(S) (Including Author, Title, Date, Pertinent Pages, Etc.)	
	Akiyoshi Baba et al., "Field Emission from an Ion-Beam-Modified Polyimide Film," Japanese Journal of Applied Physics, Publication Board Japanese Journal of Applied Physics, Tokyo, JP, Vol. 38 (1999), NR. 3A pp. L261-L263.

EXAMINER	DATE CONSIDERED
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\*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

Sheet 1 of 1